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Bib Data Sheet

CONFIRMATION NO. 3317

<b>SERIAL NUMBER</b> 10/501,080	<b>FILING OR 371(c) DATE</b> 12/14/2004 <b>RULE</b>	<b>CLASS</b> 438	<b>GROUP ART UNIT</b> 2812	<b>ATTORNEY DOCKET NO.</b> 042440
<b>APPLICANTS</b> Hiroshi Yoshida, Osaka, JAPAN; <b>** CONTINUING DATA *****</b> This application is a 371 of PCT/JP03/00139 01/09/2003 <b>** FOREIGN APPLICATIONS *****</b> JAPAN 2002-003896 10/01/2002				
Foreign Priority claimed <input type="checkbox"/> yes <input type="checkbox"/> no 35 USC 119 (a-d) conditions <input type="checkbox"/> yes <input type="checkbox"/> no <input type="checkbox"/> Met after met Allowance Verified and Acknowledged _____ Examiner's Signature _____ Initials _____		<b>STATE OR COUNTRY</b> JAPAN	<b>SHEETS DRAWING</b> 5	<b>TOTAL CLAIMS</b> 3
<b>INDEPENDENT CLAIMS</b> 1				
<b>ADDRESS</b> 38834				
<b>TITLE</b> Method for gettering transition metal impurities in silicon crystal				
<b>FILING FEE RECEIVED</b> 1050	FEES: Authority has been given in Paper No. _____ to charge/credit DEPOSIT ACCOUNT No. _____ for following:		<input type="checkbox"/> All Fees <input type="checkbox"/> 1.16 Fees ( Filing ) <input type="checkbox"/> 1.17 Fees ( Processing Ext. of time ) <input type="checkbox"/> 1.18 Fees ( Issue ) <input type="checkbox"/> Other _____ <input type="checkbox"/> Credit	